

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q77191
Koichi OHTO, et al.
Application No.: 10/650,193 Group Art Unit: 2826
Confirmation No.: 6245 Examiner: Alexander O. WILLIAMS
Filed: August 28, 2003
For: SEMICONDUCTOR DEVICE HAVING SILICON-DIFFUSED METAL WIRING LAYER AND ITS MANUFACTURING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 8, 2008, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION.....	2
AMENDMENTS TO THE CLAIMS	5
AMENDMENTS TO THE DRAWINGS.....	11
REMARKS.....	12